

Notice of References Cited	Application/Control No. 10/564,771	Applicant(s)/Patent Under Reexamination CHO ET AL.	
	Examiner Ajith Jacob	Art Unit 2169	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0108205 A1	06-2003	Joyner et al.	380/277
*	B	US-6,580,756 B1	06-2003	Matsui et al.	375/240.08
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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